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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group art unit: 2818
Examiner: Hoang Quan Tran Ho

In Re PATENT APPLICATION of:

Applicant(s):	Masaru TAKAISHI)
U.S. Serial No.:	10/577,360)
U.S. Filing Date:	April 28, 2006)
International Serial No.:	PCT/JP2004/019732)
International Filing Date:	December 24, 2004)
Priority Date Claimed:	December 26, 2003)
For:	SEMICONDUCTOR DEVICE PRODUCTION METHOD AND SEMICONDUCTOR DEVICE)
Attorney Reference:	AI 411NP)

AMENDMENT

May 5, 2009

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Examiner's Action mailed on February 5, 2009, please
amend the above-identified application as follows: